

Bits	Search Text	DBs	Time Stamp
1 6	520 524	US-PGFUB; USPAI; 2005/04/26 EPO; JPO; DERWENT; 14:06	
2 182	(chin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic	US-PGFUB; USPAI; 2005/04/26 EPO; JPO; DERWENT; 14:05	
3 7	(chin adj film) and substrate and (affinity same (organic adj semiconductor)) and (ito or glass) and inorganic and polyimide and transistor	US-PGFUB; USPAI; 2005/04/26 EPO; JPO; DERWENT; 13:59	
4 49	517 and 518	US-PGFUB; USPAI; 2005/04/26 EPO; JPO; DERWENT; 13:59	
5 6	(chin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic and polyimide and @pd>*20050111"	US-PGFUB; USPAI; 2005/04/26 EPO; JPO; DERWENT; 13:59	
6 0	(chin adj film) and substrate and (affinity same (organic adj semiconductor)) and (ito or glass) and inorganic and polyimide and transistor and @pd>*20050111"	US-PGFUB; USPAI; 2005/04/26 EPO; JPO; DERWENT; 13:59	
7 6011	337/40*59,89,89.ccls. 438/29,30,30,39.ccls.	US-PGFUB; USPAI; 2005/04/26 EPO; JPO; DERWENT; 13:59	
8 1	522 and 523 and @pd>*20050111"	US-PGFUB; USPAI; 2005/04/26 EPO; JPO; DERWENT; 13:59	
9 65	(chin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic and polyimide	US-PGFUB; USPAI; 2005/04/26 EPO; JPO; DERWENT; 13:58	
10 174	(chin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic	US-PGFUB; USPAI; 2005/02/01 EPO; JPO; DERWENT; 16:02	
11 174	(chin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic	US-PGFUB; USPAI; 2005/02/01 EPO; JPO; DERWENT; 16:01	
12 5703	257/40,59,89,89.ccls. 438/29,30,70,99.ccls.	US-PGFUB; USPAI; 2005/02/01 EPO; JPO; DERWENT; 16:01	
13 44	(chin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic and polyimide and transistor	US-PGFUB; USPAI; 2005/01/28 EPO; JPO; DERWENT; 16:35	
14 4541	(chin adj film) and affinity and substrate and organic and (ito or glass)	US-PGFUB; USPAI; 2005/01/28 EPO; JPO; DERWENT; 16:33	
15 211	(chin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass)	US-PGFUB; USPAI; 2005/01/28 EPO; JPO; DERWENT; 16:33	
16 4	("5948577" "5691011").pn.	US-PGFUB; USPAI; 2005/01/28 EPO; JPO; DERWENT; 16:32	
17 0	"09/423969".pn.	US-PGFUB; USPAI; 2005/01/11 EPO; JPO; DERWENT; 14:10	
18 0	"09/423969"	US-PGFUB; USPAI; 2005/01/11 EPO; JPO; DERWENT; 14:10	
19 1	"JP 11040354 A"	JPO; 2005/01/11 13:44	
20 1	"JP 07234314 A"	JPO; 2005/01/11 13:39	
21 1	"JP 09230127 A"	JPO; 2005/01/11 13:39	
22 1	"JP 06347637 A"	JPO; 2005/01/11 13:38	
23 1	"JP 06109912 A"	JPO; 2005/01/11 13:37	
24 1	"JP 63305920 A"	JPO; 2005/01/11 13:36	
25 2	("6373157").pn.	US-PGFUB; USPAI; 2005/01/11 EPO; JPO; DERWENT; 13:29	

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